MAR 0 7 2013

Attorney's Docket No.: 10417-039001 / F51-125462M/HW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Toshimitsu Tanigughi et al.

Art Unit : 2811

Serial No.: 09/652,044

Examiner: Samuel A. Gebremariam

Filed : August 31, 2000

: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING

THEREOF

## **BOX AF**

Title

Commissioner for Patents Washington, D.C. 20231

## AMENDMENT IN RESPONSE TO OFFICE ACTION DATED DECEMBER 2, 2002

In response to the action mailed December 2, 2002, please amend the application as follows:

RECEIVED
MAR 11 2003

## CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

MARCH.

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PATRICIA F. SUCHANEK

Typed or Printed Name of Person Signing Certificate

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